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# Measuring Infrared Reflectivity of 3D Microantennas

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Harvard 2017 B.S. Candidate

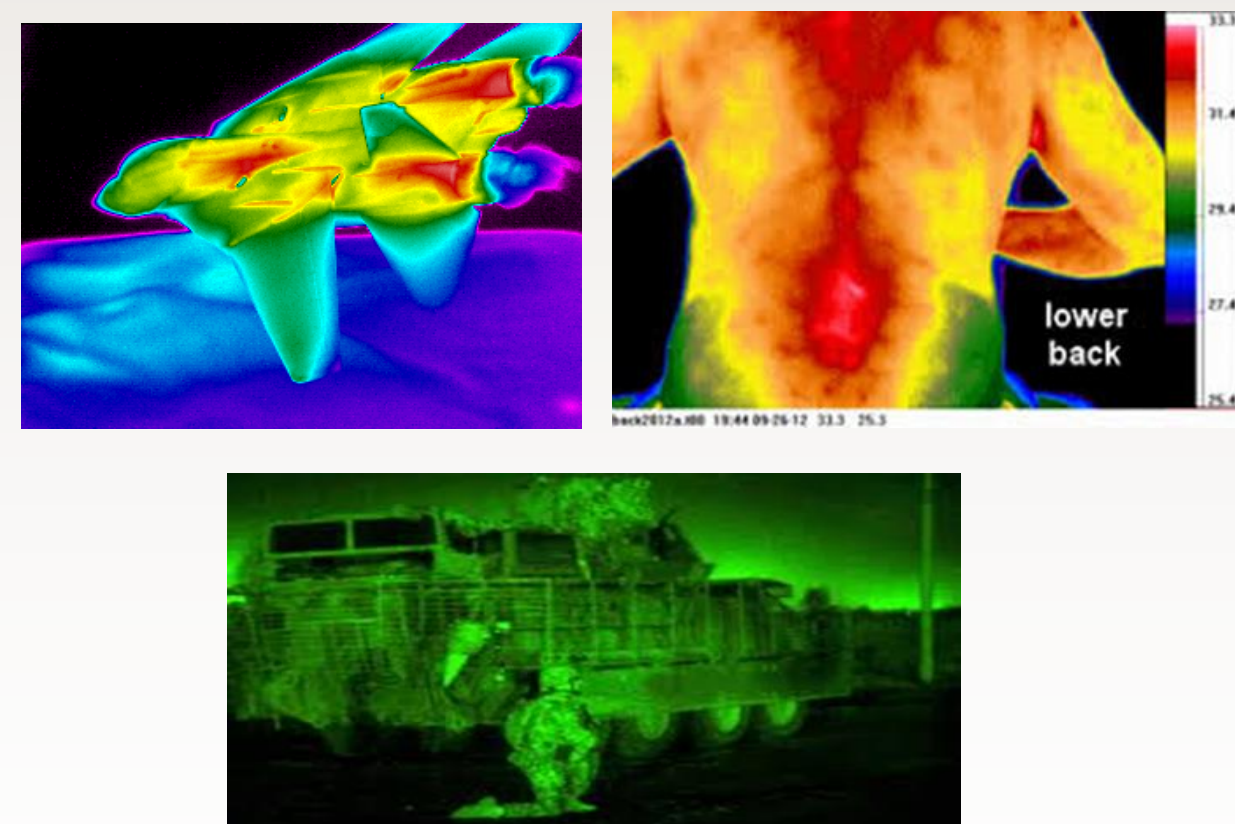
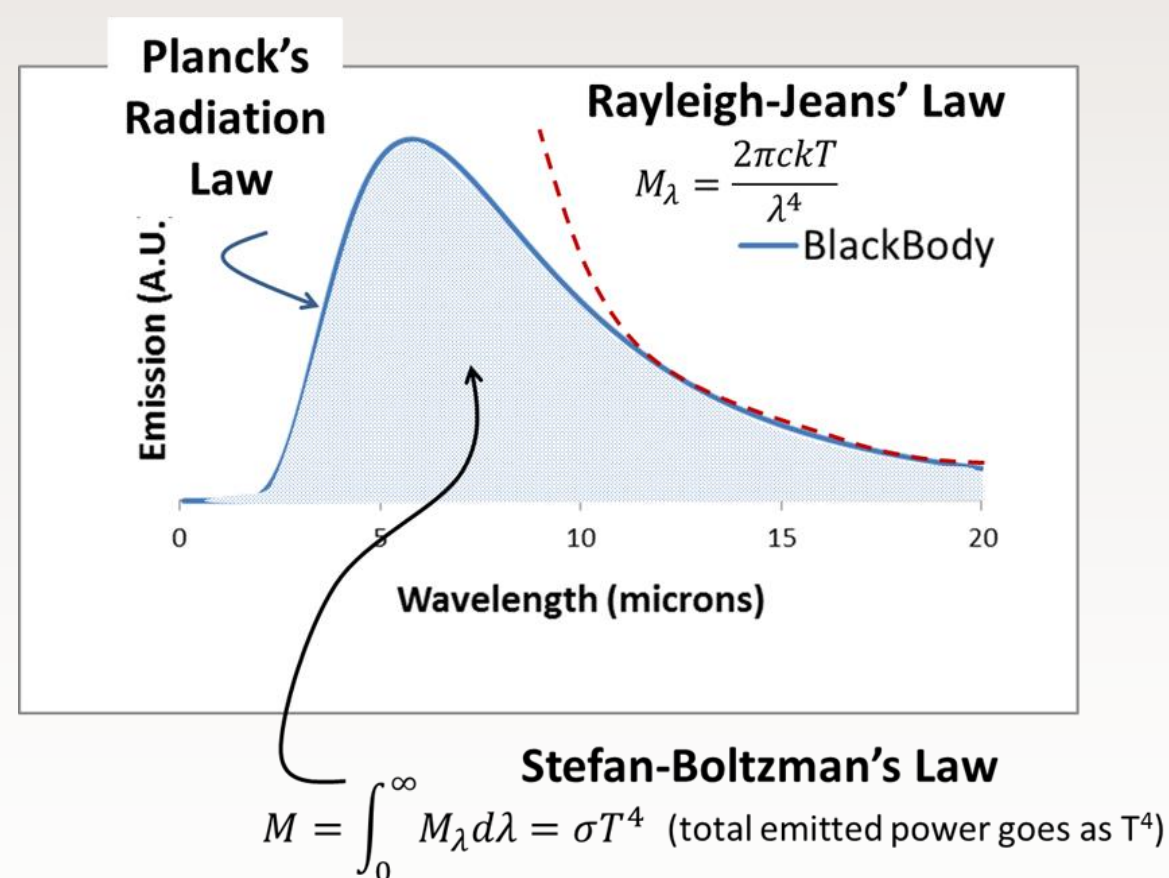
Applied Photonic Microsystems (01765)

Patrick Chu, Manager; Bruce Burckel, Mentor

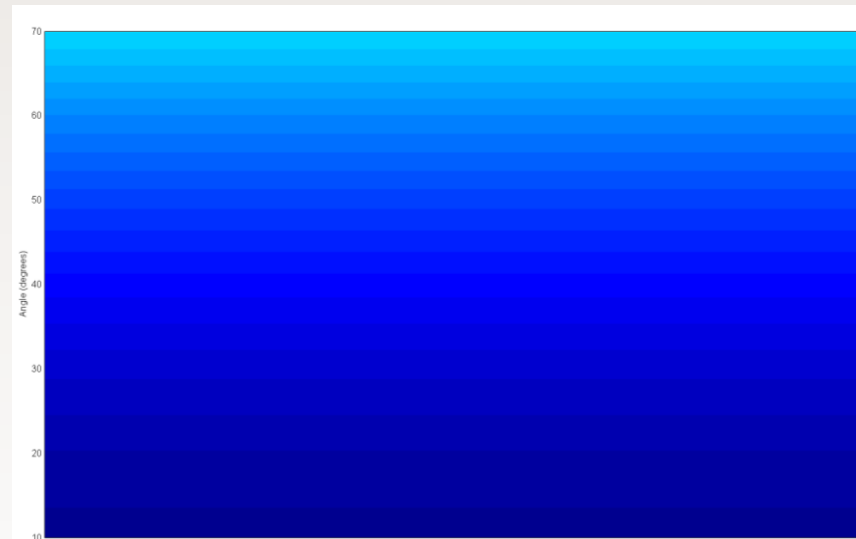
31 July, 2014

**Objective:** Understand the optical properties of 3D microstructures to be used in infrared applications

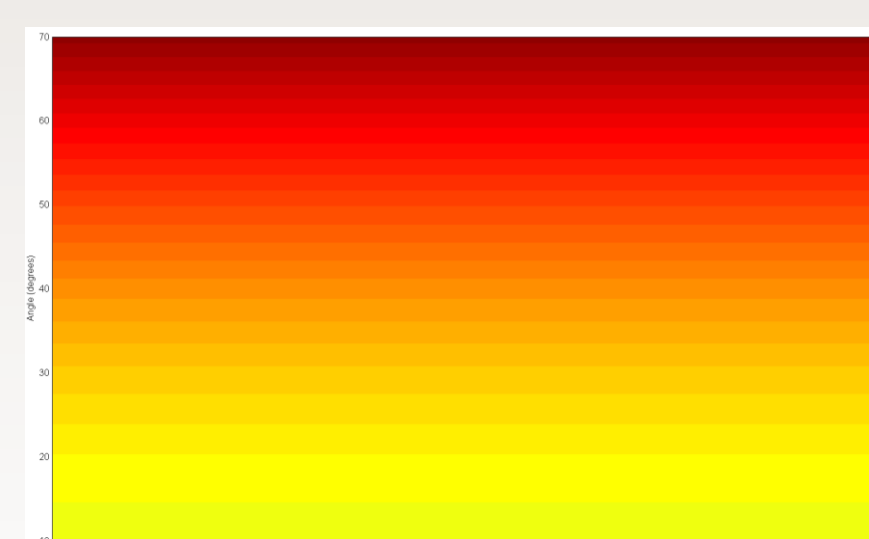
**Background:** All bodies emit thermal (IR) radiation according to Planck's law:



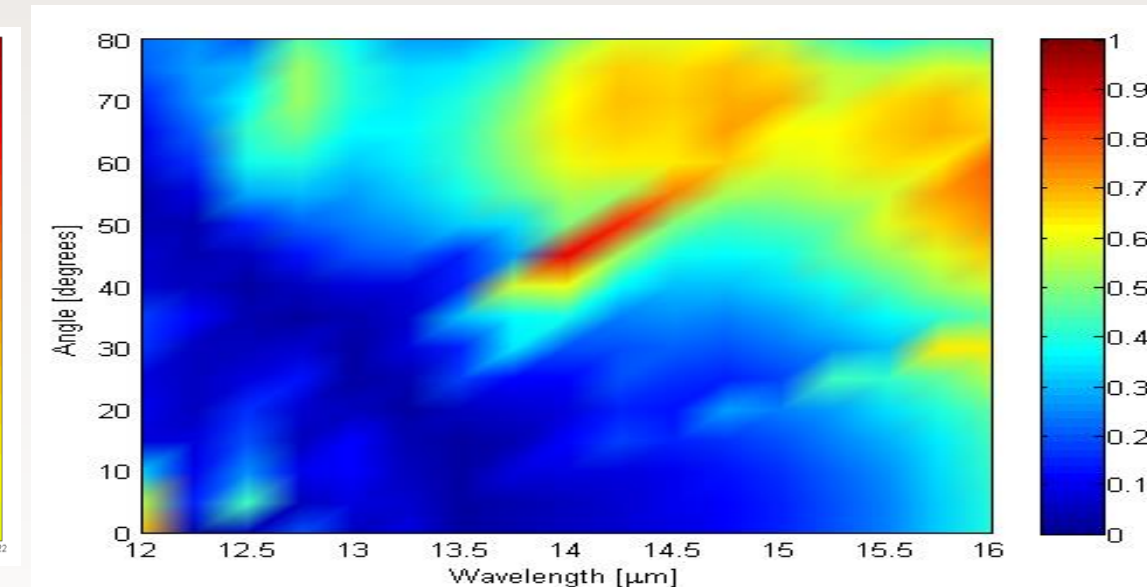
Example Reflection map for an unstructured absorptive Surface



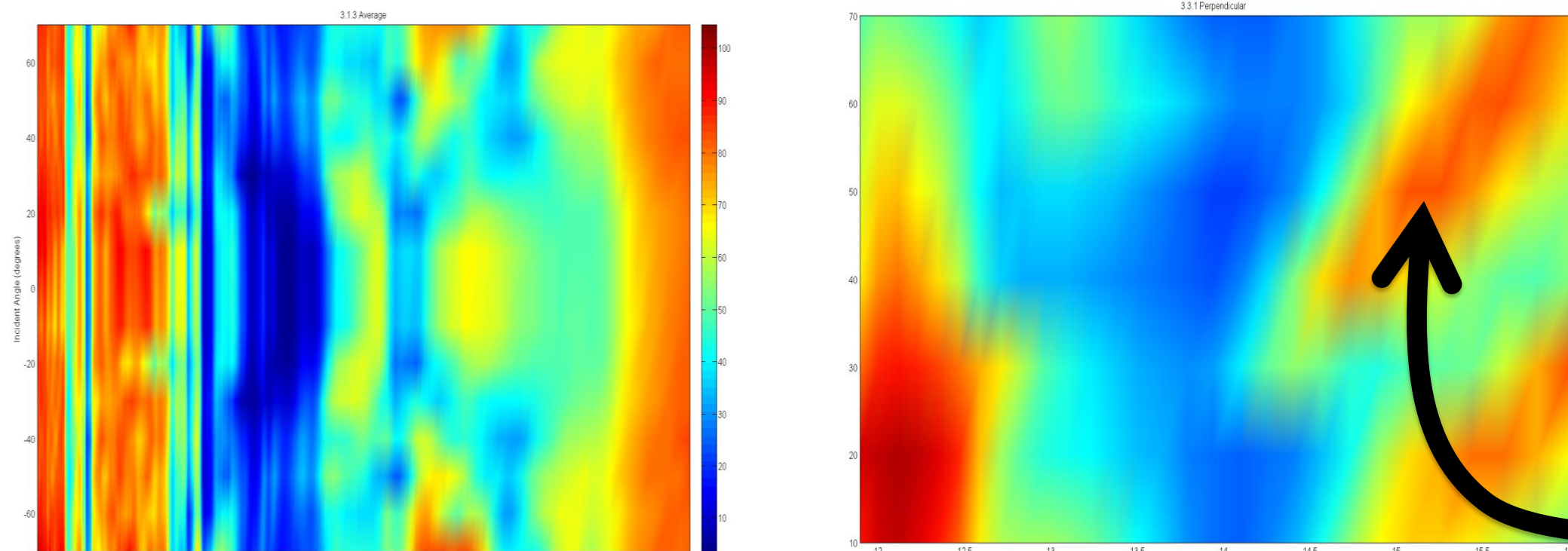
Example Reflection map for an unstructured reflective Surface



Example Reflection map for A structured electromagnetic material created with MPL



## Measured Reflectance Data of Structured Electromagnetic Surfaces Generated with MPL

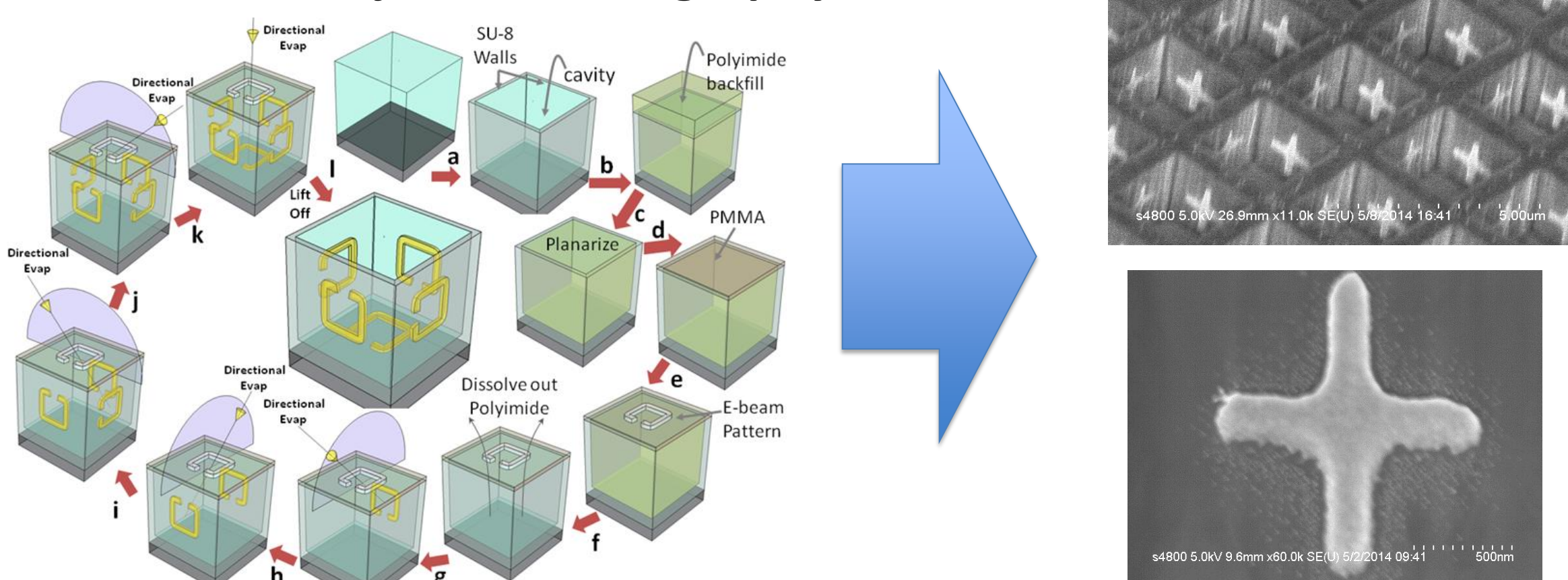


Material absorption is angle independent

SU-8 Absorption

Properly designed metallic inclusions allow for the possibility of control over both angular and wavelength dependent Reflectivity/absorption

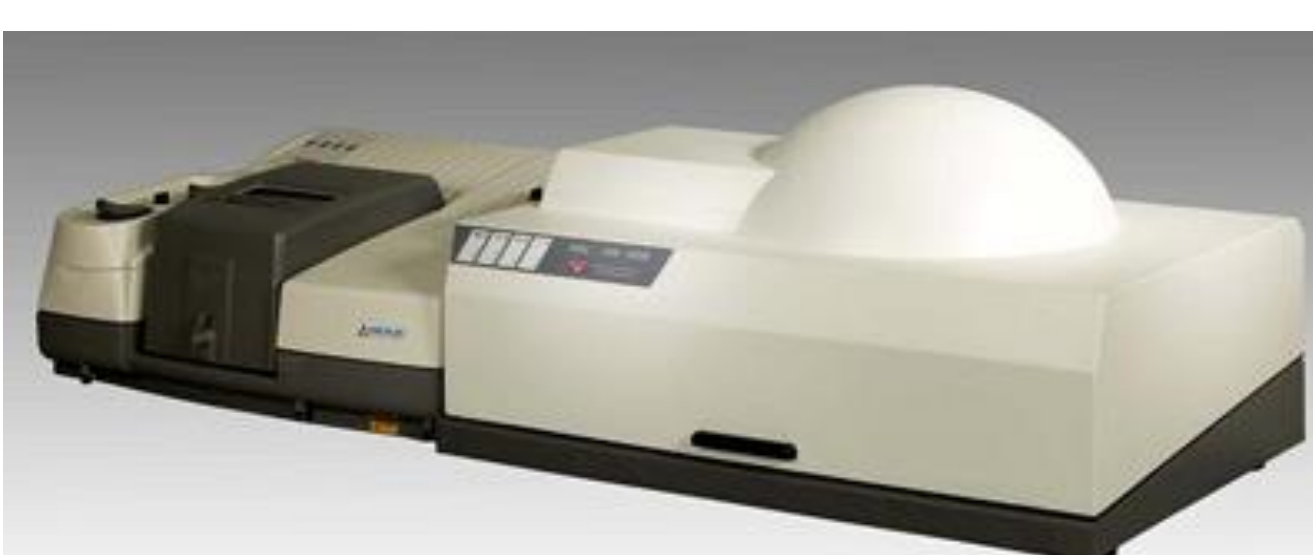
### Membrane Projection Lithography



The ability to fabricate 3D micron-scale structures allows us to interact with IR light in new ways

$$1 = R + T + A$$

**Kirchoff's Law:** Absorption and emission are equivalent, so with  $T = 0$  we can use reflectance measurements to find information about emissivity



HDR/FT-IR setup used to measure reflectance of surfaces

**Angle-dependent reflectance** suggests potential to engineer surfaces that emit radiation in a particular direction – a behavior not possible with natural unstructured materials.

**Future work:** Optimize designs for the metallic inclusions to target specific angle and wavelength combinations specific to application needs.